



ASIMMC.047AUS

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

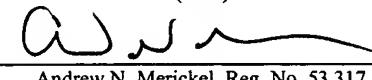
Applicant : Huotari  
App. No. : 10/601,037  
Filed : June 19, 2003  
For : METHOD TO FABRICATE  
DUAL METAL CMOS DEVICES  
Examiner : Christy Novacek  
Art Unit : 2822

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

November 4, 2004

(Date)

  
Andrew N. Merickel, Reg. No. 53,317

**AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION**

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

The present paper is submitted in response to the Final Office Action filed on August 4, 2004. As they are believed to place the application in condition for allowance and do not require extensive consideration, Applicants respectfully request entry of the following amendments and consideration of the subsequent remarks.

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.